Measurement of the quantum-confined Stark effect in InAs/In(Ga)As quantum dots with p-doped quantum dot barriers

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Abstract: The quantum-confined Stark effect in InAs/In(Ga)As quantum dots (QDs) using non-intentionally doped and p-doped QD barriers was investigated to compare their performance for use in optical modulators. The measurements indicate that the doped QD barriers lead to a better figure of merit (FoM), defined as the ratio of the change in absorption $\Delta \alpha$ for a reverse bias voltage swing to the loss at 1 $V\alpha(1\ V)$, $FoM = \Delta\alpha/\alpha(1\ V)$. The improved performance is due to the absence of the ground-state absorption peak and an additional component to the Stark shift. Measurements indicate that p-doping the QD barriers can lead to more than a 3x increase in FoM modulator performance between temperatures of -73 °C to 100 °C when compared with the stack with NID QD barriers.

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1. Introduction

Nowadays, there have been significant advancements in integrating InAs/In(Ga)As QD lasers into the silicon photonics platform [1,2] with little degradation in device performance. The degradation resilience is due to their confined nature and small size that leads to a lower chance of being affected by defects, including threading dislocations [1]. QD devices have this advantage over competing technologies, particularly quantum wells (QWs). Furthermore, QD lasers offer the prospect of greater temperature tolerance [3], which is fundamentally due to the large energy spacing of conduction states found within the dots. The larger energy spacing prevents any carriers from getting thermally excited to higher states [4] and reduces wavelength drift in the laser.

Most research on QD devices has focused on developing lasers over a native substrate and Si. With the recent improvements of QD lasers over Si showing relevant results, the focus has shifted to additional devices, including modulators and photodetectors. Despite the prospect of more efficient additional QD devices over Si, there have not been many investigations into developing *QD* modulators. This paper will explore the use of *QDs* for optical modulation.

The quantum-confined Stark effect (QCSE) is widely used in several electro-absorption modulators (EAMs) and it is present in QDs. There are numerous advantages to utilizing this effect, including faster bandwidth when compared to the plasma dispersion effect [5] exploited in current Si modulators. Additionally, the QCSE allows a shorter modulator length and reduced electrical power consumption [6,7].

The OCSE is present in both ODs and OWs [8–16]. One of the advantages of ODs devices is that they are more resilient than QW devices when growing them over Si since the QWs are always affected by defects arising from the material lattice mismatch and different thermal expansion

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coefficients. Additionally, defects in the semiconductor materials lead to uneven static electric fields across QW active regions through the onset of leakage current as demonstrated in [17,18]. Furthermore, the non-uniform static electric field leads to a non-uniform Stark shift, broadening the QCSE excitonic peak and reducing the maximum absorption, leading to smaller extinction ratios (ERs) [17,18].

On the other hand, *QDs* offer the prospect of significant electro-optic coefficients and steeper absorption edges due to their confined nature [1]. For example, the work in [8] demonstrated that the *QCSE* in *QDs* can achieve comparable *ERs* to *QWs* despite having a lower density of states by two orders of magnitude. This result highlighted the strong *QCSE* in *QD* structures due to their increased carrier confinement and suggested their potential for high-performance *EAMs*.

There have been several measurements of the QCSE in QDs [8,9,11,14]. Nevertheless, the QD stacks used in those works are very similar to the QD laser, and the stacks were not optimized to improve the QCSE for modulation.

This is not the case of the QW stacks, which were thoroughly optimized to improve the QCSE for modulation. One successful method is the incorporation of barrier doping as shown in [12]. The study demonstrated that incorporating a modulation-doped superlattice in a multi-QW structure can lead to equivalent ERs while reducing the applied voltage by almost half. The enhancement was attributed to the modification of the potential by the doping profile to create higher polarizability of the electron and hole wavefunctions. This improvement would lead to more efficient QW modulators with reduced power consumption [19].

The same technique was applied to the QD laser by doping the QD barriers and offering better performance as described in [20]. Nevertheless, the method has not been investigated for modulation, and there is no report on the influence of QD barrier doping on the QCSE.

In this paper, we investigate the influence of p-doping the QD barriers on the QCSE and compare it with non-intentionally doped (NID) barriers with temperatures between $-73^{\circ}C$ and $100^{\circ}C$. The QCSE in both stacks were measured, and the stacks were compared for modulation using the $FoM = \Delta\alpha/\alpha(1\ V)$, where $\Delta\alpha$ is the change in absorption for a given reverse bias voltage swing and $\alpha(1\ V)$ is the absorption under an applied reverse bias of $1\ V\ [21,22]$. The measurements show that the p-doping in the QD barriers offers up to 3x larger FoM between $-73^{\circ}C$ and $100^{\circ}C$.

Comparison of the quantum-confined Stark effect with p-doped and nonintentionally doped quantum dot barriers

This work measured the *QCSE* in the stacks shown in Table 1 and compared them for modulation. The only difference between the stacks is that the *QD* barrier is p-doped (*PD*) or left *NID*; the barrier is highlighted in bold in Table 1. This work considers that a *NID* semiconductor has a doping concentration below $<1 \cdot 10^{16} \ cm^{-3}$. Additionally, we compared the performance from $-73^{\circ}C$ to $100^{\circ}C$ by using a heater and a heat sink.

The stacks in Table 1 were grown using molecular beam epitaxy on an n-doped GaAs substrate. The only difference between the stacks is the 10~nm GaAs QD barrier layer highlighted in bold, which is either p-doped $(5 \cdot 10^{17}~cm^{-3})$ or left $NID~(<1 \cdot 10^{16}~cm^{-3})$. The p-doping concentration in the QD barrier of $5 \cdot 10^{17}~cm^{-3}$ is equivalent to 10 holes per dot. In both stacks, the InAs~QD areal density is $5 \cdot 10^{10}~cm^{-2}$. The QD active region stack consists of 7 dot-in-a-well layers with a total thickness of 350~nm. Finally, the waveguide core has an $Al_{0.4}Ga_{0.6}As$ cladding layer above and below with a thickness of 1400~nm. The structure contains highly p-doped top and n-doped bottom GaAs layers for making electrical contacts. To handle strain between GaAs and $Al_{0.4}Ga_{0.6}As$, there are 10~repetitions of 5~nm $GaAs/Al_{0.4}Ga_{0.6}As$.

The QCSE was measured using the segmented contact method [23] using the structure shown in Fig. 1. Two identical structures were fabricated with the stacks shown in Table 1. The top gold (Au) contacts have dimensions $100 \ \mu m \times 278 \ \mu m$, and the separation between them is $14 \ \mu m$.

Table 1. Layer structure for *QD* stacks. The only difference between the stacks is the *QD* barrier doping highlighted in bold, which is p-doped (5 · 10¹⁷ cm⁻³) or left *NID* (<1 · 10¹⁶ cm⁻³). *P* stands for p-doped, and *N* for n-doped. The column *Repetitions* represents the number of times a set of layers is repeated in the stack, e.g., there are 7x repetitions of the *QD* active region.

Material	Thickness	Doping	Repetitions
GaAs	300 nm	$P(10^{19} cm^{-3})$	1×
GaAs/Al _{0.4} Ga _{0.6} As	5 nm	$P (5 \cdot 10^{17} \text{ cm}^{-3})$	10×
$Al_{0.4}Ga_{0.6}As$	1400 nm	$P(2 \cdot 10^{17} \text{ cm}^{-3})$	1×
$Al_{0.4}Ga_{0.6}As$	30 nm	NID	1×
GaAs/Al _{0.4} Ga _{0.6} As	2 nm	NID	12×
GaAs	17.5 nm	NID	
GaAs	10 nm	$P(5 \cdot 10^{17} cm^{-3})$	
		or NID ($< 1 \cdot 10^{16} \ cm^{-3}$)	
GaAs	10 nm	NID	
GaAs	5 nm	NID	7×
$In_{0.16}Ga_{0.84}As$	5 nm	NID	
InAsQD	3 <i>ML</i>	NID	
$In_{0.16}Ga_{0.84}As$	2 nm	NID	
GaAs	42.5 nm	NID	1×
GaAs/Al _{0.4} Ga _{0.6} As	2 nm	NID	12×
$Al_{0.4}Ga_{0.6}As$	30 nm	NID	1×
$Al_{0.4}Ga_{0.6}As$	1400 nm	$N(2 \cdot 10^{18} \ cm^{-3})$	1×
GaAs/Al _{0.4} Ga _{0.6} As	5 nm	$N(2 \cdot 10^{18} \ cm^{-3})$	10×
GaAs	200 nm	$N(2 \cdot 10^{18} \ cm^{-3})$	1×

The top layer in the stack is doped over $1 \cdot 10^{19}$ cm⁻³ to guarantee Ohmic contacts with Au. Gaps of 14 μm in length and 700 nm in depth were etched in the top layers to isolate the contacts electrically. During the measurement, the leakage current was compensated as the resistance between contacts and the leakage current change with temperature from $-73^{\circ}C$ to $100^{\circ}C$.

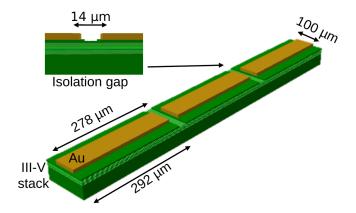


Fig. 1. Schematic of multisection device used to measure the *QCSE* in the stacks of Table 1.

The measurements of the *QCSE* are shown in Fig. 2(a) for the stack with doped *QD* barriers and Fig. 2(b) for the stack with *NID QD* barriers. Both figures show the change in absorption $\Delta \alpha$ for a reverse bias voltage swing of 9 *V* and the absorption $\alpha(1\ V)$ at a reverse bias of 1 *V* for $21^{\circ}C$, $50^{\circ}C$, $75^{\circ}C$, and $100^{\circ}C$. The pre-biased value of 1 *V* is used to mitigate the modulator's capacitance penalty as in [9].

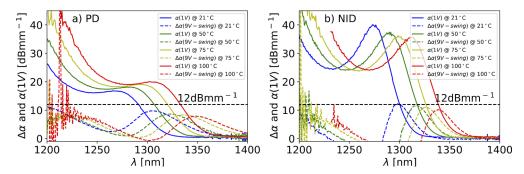


Fig. 2. Change in absorption $\Delta \alpha$ for a voltage swing of 9 V and absorption at a pre-biased value of 1 V α (1 V) for p-doped (PD) (a) and NID (b) QD barriers for 21°C, 50°C, 75°C, and 100°C.

When comparing the $\Delta\alpha$ of both stacks in Fig. 2(a) and (b), there is a slight decrease in $\Delta\alpha$ with temperature. This will lead to a modulator with a stable ER from 21°C to 100°C for both stacks. Additionally, the stack with $NID\ QD$ barriers has the largest $\Delta\alpha$ value of around 12 $dBmm^{-1}$, which will lead to a larger ER. Nevertheless, it also has a larger material absorption $\alpha(1\ V)$, which will lead to a larger insertion loss (IL).

Regarding $\alpha(1V)$ shown in Fig. 2(a), the stack with barrier doping does not exhibit an absorption peak at the QD ground-state wavelength. The ground-state absorption peak suppression is attributed to the injection of holes in the QD valence ground-state from the p-doped barrier. The holes inhibit the excitation of electrons from the valence ground-state to the conduction ground-state and inhibit photon absorption. Furthermore, the doping in the barriers will contribute to increasing the absorption. Nevertheless, the contribution is minimal due to the small area of the barriers compared to the entire active region. On the other hand, the stack with NID barriers has the expected ground-state absorption peak, as shown in Fig. 2(b).

Additionally, the maximum absorption $\alpha(1\ V)$ around 1275 nm of the stack with doped barriers increases slightly with increasing temperature, as shown in Fig. 2(a). This behavior is attributed to the redistribution of carriers in the valence ground-states as the temperature increases. The redistribution leads to a greater occupancy probability for electrons in the top QD valence states, which increases photon absorption. On the other hand, the ground-state absorption peak of the stack with NID barriers in Fig. 2(b) decreases with increasing temperature as expected from the QCSE in QDs. The same trend was measured in [24].

To investigate the trends further, the *QCSE* ground-state absorption peak for the stack with p-doped (PD) and $NID\ QD$ barriers as a function of reverse bias was measured in Fig. 3(a) for three temperatures $-73^{\circ}C$, $21^{\circ}C$, and $100^{\circ}C$. Additionally, the absorption peak wavelength shift is represented in Fig. 3(b). The ground-state absorption peak wavelength is the wavelength that has the ground-state absorption peak.

As shown in Fig. 3(a), the stack with *NID* barriers has a constant reduction in the ground-state absorption peak with increasing reverse bias at $-73^{\circ}C$, $21^{\circ}C$, and $100^{\circ}C$. As the reverse bias increases, the increased static electric field pulls the electrons and holes in opposite directions inside the *QDs*. This phenomenon leads to a reduction in the overlap between the carriers' wavefunctions and contributes to reducing the photon absorption [25].

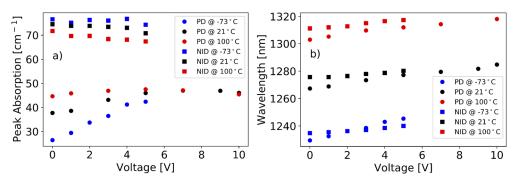


Fig. 3. The change in ground-state absorption peak (a) and absorption peak wavelength (b) for $-73^{\circ}C$, $21^{\circ}C$, and $100^{\circ}C$ for the stack with p-doped (*PD*) and *NID* barriers.

On the other hand, the stack with p-doped QD barriers has different behavior. Below moderate reverse bias ($< 5.5 \ V$), the holes at the valence state's top inhibit the photon absorption. As the reverse bias increases, the built-in static electric field depletes the holes from the top valence state, allowing photons to excite electrons from the valence ground-state to the bottom of the conduction ground-state. For voltages below $4 \ V$, the ground-state absorption peak is smaller at $-73^{\circ}C$ rather than at $100^{\circ}C$ due to more electrons being thermally excited to the top of the valence ground-state at higher temperatures. For the same reason, the gradient of the ground-state absorption peak at $-73^{\circ}C$ is more significant between $0 \ V$ and $5.5 \ V$.

The ground-state absorption peak will increase with a reverse bias for all temperatures until all holes are entirely depleted from the top of the valence ground-state. As shown in Fig. 3(a), all holes are depleted around 5.5 V, and the absorption peak starts to decrease beyond 5.5 V for the same reason as the stack with NID barriers. The built-in static electric field pulls the carriers in opposite directions reducing the carrier's wavefunction overlap and the photon absorption.

The wavelength shift of the ground-state absorption peak is shown in Fig. 3(b). The stack with doped barriers shows a more significant shift than the stack with *NID* barriers. For reverse biases between 1 V and 5 V, red-shifts at $-73^{\circ}C$ are 13 nm for the stack with doped barriers and 5 nm for the stack with NID barriers. The shift difference is more considerable at $-73^{\circ}C$, and it decreases with increasing temperature.

Both stacks show the Stark shift present in the QCSE. Nevertheless, the stack with doped barriers has additional contributions to the red-shift. One comes from the QD layers having a larger static electric field strength when compared with the stack with NID barriers. The larger static electric field is due to the QD layers being surrounded by doped GaAs layers. The static electric field distribution across the QD active region for both stacks is shown in Fig. 4 and it was calculated using nextnano [26].

The black line at the bottom of the figure indicates the position of the doped barriers. Figure 4 highlights the significantly stronger field across the *QDs* of the stack with doped barriers. Therefore, the larger static electric field would cause a more substantial red-shift.

The other shift contribution originates from the removal of holes from the highest valence states as the static electric field increases with reverse bias. As holes are depleted from the top of the valence states, longer wavelength (lower energy) transitions are allowed.

In order to determine which stack design is better for modulation, the stacks were compared using the $FoM = \Delta\alpha/\alpha(1\ V)$. The FoM maximizes $\Delta\alpha$ to have a large ER and minimizes $\alpha(1\ V)$ to reduce the IL. The FoM is shown in Fig. 5(a) for a 4 V-swing and in Fig. 5(b) for a 9 V-swing. A maximum swing of 9 V was used to ensure working below the breakdown static electric field of the materials. As shown in Fig. 5, the stack with p-doped QD barriers outperforms the stack with NID barriers offering up to 3x enhancement in the FoM from $-73^{\circ}C$ to $100^{\circ}C$.

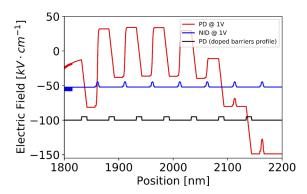


Fig. 4. Static electric field distribution across the QD active region for the stacks with doped (red line) and NID (blue line) barriers for a 1 V reverse bias at $21^{\circ}C$. The black line shows the position of the doped barriers, and the QDs are between them. The static electric field was numerically calculated using nextnano [26].

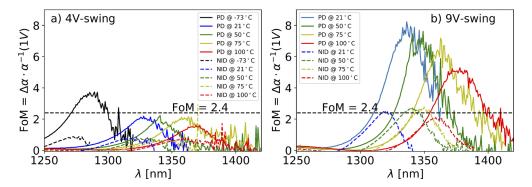


Fig. 5. *FoM* for a 4 *V*-swing (a) and 9 *V*-swing (b) for both stacks with p-doped and *NID* barrier vs temperature.

Several factors explain the better performance of the stack with doped QD barriers. As shown in Fig. 2, the $\Delta\alpha$ of the stack with NID barriers is around $12~dBmm^{-1}$, and it is slightly larger than the stack with doped barriers. Nevertheless, the $\alpha(1~V)$ is more significant in the stack with NID barriers. In this comparison, we only considered the material absorption contribution to the IL since both stacks will have a similar loss due to wall roughness in the modulator's waveguide.

Additionally, the extra red-shift in the stack with doped barriers shifts away the maximum $\Delta \alpha$ from the absorbing edge of the absorption spectrum $\alpha(1\ V)$ represented in Fig. 2(a) offering a better trade-off $\Delta \alpha/\alpha(1\ V)$. Overall, the *FoM* is better for the stack with doped barriers when considering all factors.

To explain the results in Fig. 5(a) further, the *FoM* of the stack with *NID* barriers is below $\sim 0.6 - 0.9$ from $-73^{\circ}C$ to $100^{\circ}C$ for a 4 *V*-swing. On the other hand, the *FoM* of the stack with doped barriers is ~ 4 at $-73^{\circ}C$ and it is around ~ 2.4 from $21^{\circ}C$ to $100^{\circ}C$. Consequently, for a 4 *V*-swing the *FoM* of the stack with doped barriers is $\sim 4.5x$ times larger than the stack with *NID* barriers.

Considering the results for a 9 V-swing shown in Fig. 5(b), the maximum FoM of the stack with NID barriers is around 2.4 from $21^{\circ}C$ to $100^{\circ}C$. On the other hand, the maximum FoM for the stack with doped barriers starts at ~ 8 at $21^{\circ}C$ and degrades to ~ 6 at $100^{\circ}C$. Consequently, the FoM of the stack with doped barriers is at least $\sim 3x$ (at $100^{\circ}C$) times larger than the stack with NID barriers. Finally, the FoM = 2.4 of the stack with NID barriers at 9 V-swing is the same

as the stack with doped barriers with a 4 V-swing. This result implies that a modulator using the stack with doped barriers may need $\sim 5~V$ less driving voltage which would significantly reduce power consumption.

3. Comparison with the state-of-the-art

The QCSE was measured in QDs in slightly different stacks. Using different stack configurations can lead to changes in the QCSE, which will produce modulators with various performances. All the papers measuring the QCSE in QDs are summarized in Table 2.

Table 2. Measurements of the *QCSE* in *QDs* with different stacks. The values of the *ERs* and the *ILs* were calculated using a length of 1 *mm* to obtain *ERs* around 10 *dB*. The values marked with a - (dash) are not available. *V_{reverse}* stands for the reverse bias voltage, *BW* for the electrical bandwidth, and *λ* for the wavelength.

	Cambridge [14] (2007)	NTU [11] (2009)	NSYSU [8] (2011)	Glasgow [9] (2019)	Our Work [<i>NID</i>] ^b	Our Work [PD] ^b
ER	3.5 dB	10 <i>dB</i>	$\sim 10 dB^a$	~ 12 <i>dB</i>	7.6 <i>dB</i>	9 <i>dB</i>
IL	-	-	-	$\sim 3 dB$	3.9 dB	2.5 dB
$V_{reverse}$	8 V	10 V	5 V	11 V	9 V	9 V
BW	2 GHz	-	3.3 <i>GHz</i>	-	-	-
λ	1300 nm	1328 nm	1300 nm	1310 nm	1311 nm	1316 nm

^aER taken from 1 V in Fig. 4 [8] to be consistent with the rest of the papers.

Several data/telecom applications require a minimum ER of around $20 \, dB$. For the mentioned ER, the sample with NID barriers will have a length of about $2.6 \, mm$ and a material absorption contribution to the IL around $10.3 \, dB$. For most applications, that IL results in most optical interconnects going over the power budget. On the other hand, the sample with doped barriers will require $2.2 \, mm$. The material absorption contribution to the IL will be around $5.6 \, dB$, which will not exceed most optical interconnects power budgets.

This comparison only considers the material loss contribution to the *IL*. To compare both design stacks, all *ER* and *IL* were calculated assuming a modulator length of 1 mm to obtain an $ER \sim 10 \ dB$.

The work presented in [14] reported the second-largest bandwidth around 2 GHz but the 3.5 dB ER for a 8 V-swing is significantly lower than the one presented in this work. On the other hand, the ER achieved in [11] and [8] are around 10 dB, which is a similar value to the one presented in this paper. However, stacks have 10 ([11]) and 12 ([8]) QD layers. The additional QD layers absorb additional light due to a more overlap between the absorbing QDs and the optical mode. Having a thicker active region will lead to a smaller electrical bandwidth.

Finally, the work presented in [9] offers similar performance to this work. Nevertheless, it requires a larger driving voltage around 11 V-swing, and the stack has a higher QD density around $5.9 \cdot 10^{10}$ cm⁻² and 8 QD layers.

To conclude, the stack with *NID* barriers offers similar performance to the state-of-the-art shown in Table 2. Nevertheless, when the barriers are doped, the efficiency of the *QCSE* for modulation is boosted, offering better performance than the state-of-the-art in terms of *FoM*, driving voltage, electrical power consumption, and operational temperature from $-73\,^{\circ}C$ to $100\,^{\circ}C$.

4. Conclusion

This work measured the QCSE in InAs/In(Ga)As QDs using NID and p-doped QD barriers. The measurements indicate that doping QD barriers lead to a $FoM = \Delta \alpha/\alpha(1\ V)$ at least 3x larger

^bThe values are estimated at $21^{\circ}C$.

than the stack with undoped barriers from $-73^{\circ}C$ to $100^{\circ}C$. The better performance is due to the absence of the ground-state absorption peak and an additional component to the Stark shift due to hole depletion in the valence ground-state and a larger static electric field. To conclude, doping barriers offer better performance than the state-of-the-art stacks in terms of *FoM*, driving voltage, electrical power consumption, and operational temperature from $-73^{\circ}C$ to $100^{\circ}C$.

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Data availability. Data underlying the results presented in this paper are not publicly available at this time but may be obtained from the corresponding author upon reasonable request.

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